

DOCKET NO: 279648US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YOSHITAKE NATSUME, ET AL. : ATTN: APPLICATION DIVISION  
SERIAL NO: NEW U.S. PCT APPLICATION :  
BASED ON PCT/JP04/05527  
FILED: HEREWITH :  
FOR: NEGATIVE ELECTRODE FOR :  
LITHIUM SECONDARY CELL,  
LITHIUM SECONDARY CELL  
EMPLOYING THE NEGATIVE  
ELECTRODE, FILM DEPOSITION  
MATERIAL B USED FOR  
FORMING NEGATIVE  
ELECTRODE, AND PROCESS FOR  
PRODUCING NEGATIVE  
ELECTRODE

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.